

Calculations for Non-Uniform Cathode Distributions

Martin Dohlus, 23. Jan. 2017

see also: [September 2016](#)

http://www.desy.de/xfel-beam/s2e/talks/2016_09_12/GUN.pdf

http://www.desy.de/xfel-beam/s2e/talks/2016_09_12/gun.avi

there is nothing new:

it is just the conventional tracking with Poisson “space charge” fields;

it is implemented in 3D while Astra is “rz” at cathode;

problems with the ode-solver: time dependent mesh and birth/death of particles

my dirty solutions for that

- Poisson solver for free space (fields without “history”)
- tracking of particles without birth and death
- EM fields and Lorentz force with mirror charges
- mirror charges in rest frame
- birth: my simple injection model
- tracking with birth
- example

Poisson solver for free space (fields without “history”)

Lorentz transformation

particle mesh method:

particles $\{q_\nu, \mathbf{r}_\nu\}$ are **binned** to cells of an equidistant mesh

→ q_{ijk} = charge in cell i,j,k

$G(\mathbf{r})$ = potential of a mesh cell with charge = 1 C
(analytic formula)

$g_{ijk} = G(\mathbf{r}_{ijk})$ discrete Green’s function

$v_{ijk} = q_{ijk} \otimes g_{ijk}$ potential at cell centers
(fast **convolution**)

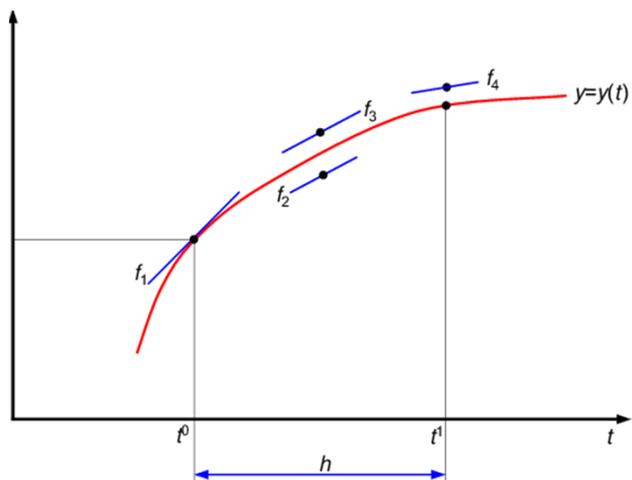
→ $E_{xyz,ijk}$ E-field on staggered grid

inverse Lorentz transformation

interpolation to particle positions $\mathbf{E}(\mathbf{r}_\nu)$

numerical effort

tracking of particles without birth and death



this is Runge-Kutta, 4th order,
it needs 4 evaluations per step

or Dormand-Prince of 5th order needs 6 evaluations

or other methods ...

a single evaluation: $\frac{d}{dt} \{\mathbf{r}_v, \mathbf{p}_v\} = f(t, \{\mathbf{r}_v, \mathbf{p}_v\})$ equation of motion

$$= \{\mathbf{v}_v(\mathbf{p}_v), q_0(\mathbf{E}(\mathbf{r}_v, t) + \mathbf{v}_v(\mathbf{p}_v) \times \mathbf{B}(\mathbf{r}_v, t))\}$$

$$\mathbf{E}, \mathbf{B} = \mathbf{E}^{(\text{external})}, \mathbf{B}^{(\text{external})} + \underbrace{\mathbf{E}^{(\text{self})}, \mathbf{B}^{(\text{self})}}_{\text{needs one Poisson computation per step}}$$

needs one Poisson computation per step

but this is not the only problem!

not the only problem:

the m^{th} order accuracy is reached if the right hand side $f(t, \{\dots\})$ is sufficiently **smooth**

this is the case for many external fields (described by analytic functions or field maps)

external fields (magnets, cavities) can be strong and **need high accuracy**

“beam dynamics” uses **hard edged models**; they are **not smooth**

→ (i) use soft fields (as in nature) or (ii) special treatment of edges

particle-mesh methods calculate the **self field on a mesh**

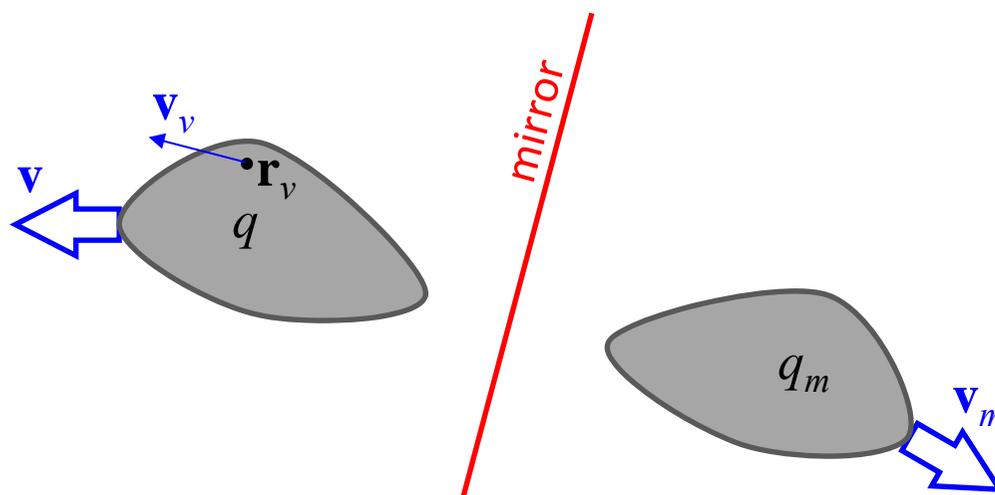
self fields are usually weak or moderate and need **less accuracy**

not in the gun: self fields may be larger than external fields (f.i. SC limit)

but: particle distribution changes shape even in one track step; therefore the binning changes and the **source term is not necessarily continuous** in time; this may spoil the accuracy of higher order integrators; try everything to avoid this:

- (i) do not change mesh properties **in one step**; if possible: move mesh with beam; change mesh **between steps** to avoid systematic mesh artefacts (→ μB effects)
- (ii) use better methods to calculate continuous source distributions from discrete particles

EM fields and Lorentz force with mirror charges



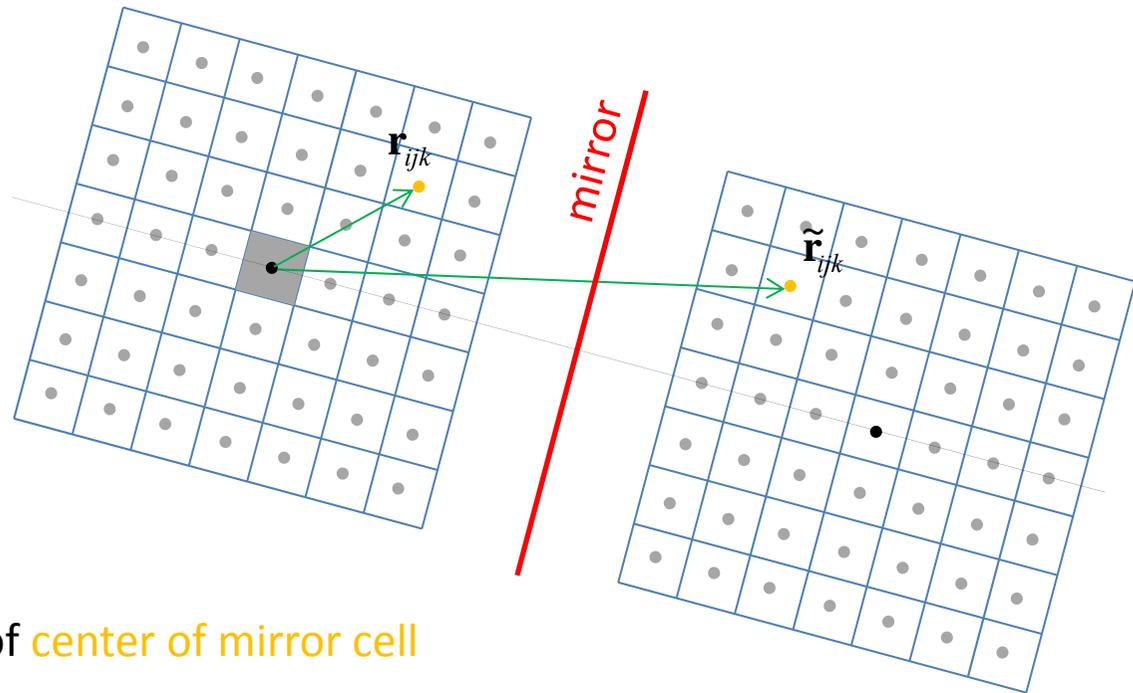
field of q in original rest frame $\mathbf{E}_0(\mathbf{r})$	\xrightarrow{LT}	$\mathbf{E}(\mathbf{r}, t) = \mathbf{E}(\mathbf{r} - \mathbf{v}t)$	fields in lab-frame
field of q_m in mirror rest frame $\tilde{\mathbf{E}}_0(\mathbf{r})$	$\xrightarrow{LT_m}$	$\tilde{\mathbf{E}}(\mathbf{r}, t) = \tilde{\mathbf{E}}(\mathbf{r} - \mathbf{v}_m t)$	

Lorentz force \mathbf{F}_v to particle at \mathbf{r}_v with velocity \mathbf{v}_v

$$\mathbf{F}(\mathbf{r}_v, t) = q_0 \left\{ \mathbf{E}(\mathbf{r}_v, t) + \tilde{\mathbf{E}}(\mathbf{r}_v, t) + \mathbf{v}_v \times (\mathbf{B}(\mathbf{r}_v, t) + \mathbf{B}(\mathbf{r}_v, t)) \right\}$$

$$\mathbf{F}(\mathbf{r}_v, t) = q_0 \left\{ 1 + \frac{\mathbf{v}_v \times \mathbf{v} \times}{c^2} \right\} \mathbf{E}(\mathbf{r}_v, t) + q_0 \left\{ 1 + \frac{\mathbf{v}_v \times \mathbf{v}_m \times}{c^2} \right\} \tilde{\mathbf{E}}(\mathbf{r}_v, t)$$

mirror charges in rest frame



$$\tilde{\mathbf{r}}_{ijk} = \mathbf{M}\{\mathbf{r}_{ijk}\}$$

location of **center of mirror cell**

$$\tilde{g}_{ijk} = G(\tilde{\mathbf{r}}_{ijk})$$

potential of **source cell** at mirror points

$$\tilde{v}_{ijk} = q_{ijk} \otimes \tilde{g}_{ij(-k)}$$

potential of source distribution at mirror points

$$\hat{v}_{ijk} = -q_{ijk} \otimes \tilde{g}_{ij(-k)}$$

potential of mirror charges at original points

$$\rightarrow \tilde{\mathbf{E}}_0(\mathbf{r}_v)$$

contribution of mirror charges to field in rest frame

birth: my simple injection model

particle “ ν ” is born (injected) at time t_ν with initial conditions $\mathbf{r}_\nu^{(i)}, \mathbf{p}_\nu^{(i)}$

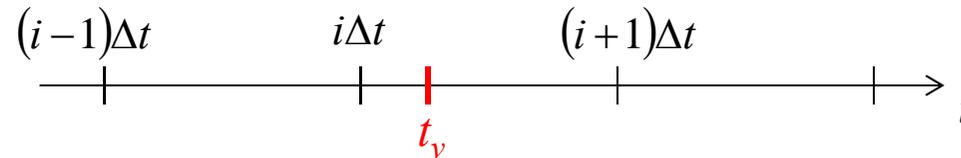
a random generator is used to generate these initial conditions $\{t_\nu, \mathbf{r}_\nu^{(i)}, \mathbf{p}_\nu^{(i)}\}$ before the simulation

be careful with Hammersly distributions !!!

in principle it is possible to generate particles “on the fly” with a probability that depends also depends on the local electric field

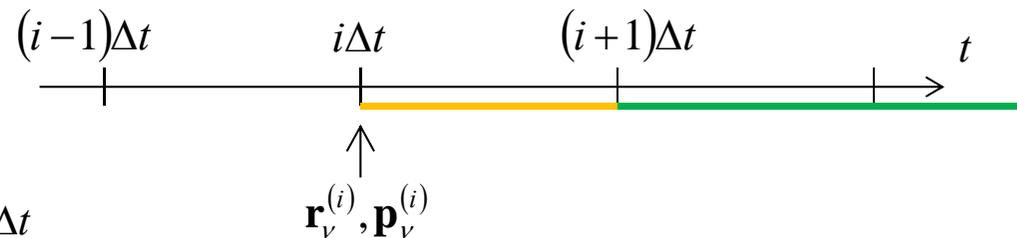
tracking with birth

particle “ v ” is born (injected) at time t_v with initial conditions $\mathbf{r}_v^{(i)}, \mathbf{p}_v^{(i)}$



it is not possible to choose the track steps so that the particles are injected between steps; there are too many particles to be started!

there are a couple of dirty tricks to start particles inside of an integration step; I used the following:



for $t = i\Delta t \rightarrow (i+1)\Delta t$:

neglect contribution of “ v ” to space charge field in the injection step

modify equation of motion for this particle for this step: $\frac{d}{dt}(\mathbf{r}_v, \mathbf{p}_v) = \left(i+1 - \frac{t_v}{\Delta t}\right) f(t, (\mathbf{r}_v, \mathbf{p}_v))$

for $t > (i+1)\Delta t$: consider “ v ” and track as usual

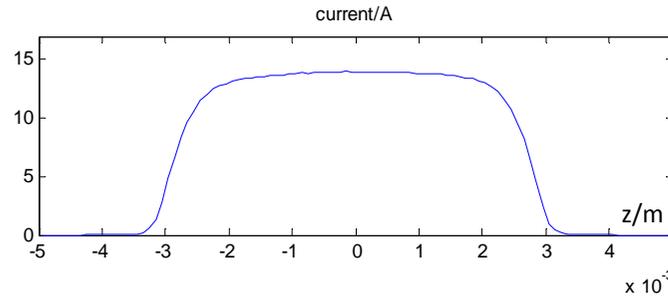
use a low order integrator with many **short time steps**!

example

case: XFEL from cathode to 2.6 m (after solenoid, before ACC1)

bunch (prototype): 250 pC, see <http://www.desy.de/xfel-beam/s2e/xfel/Nominal/nom250pC.html>

longitudinal profile (at 2.6m)

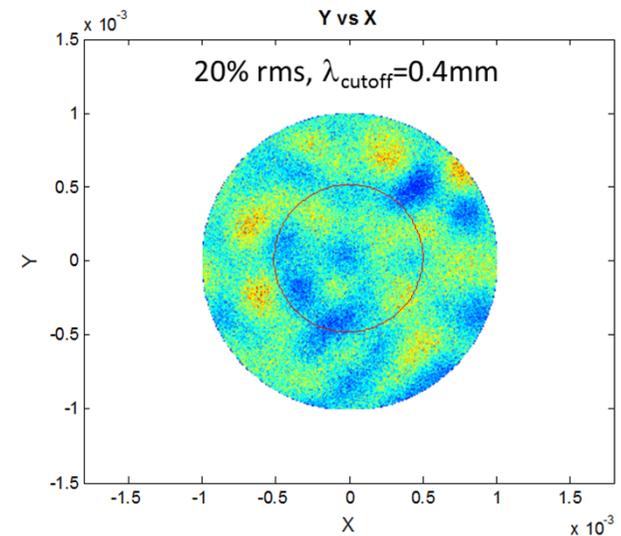
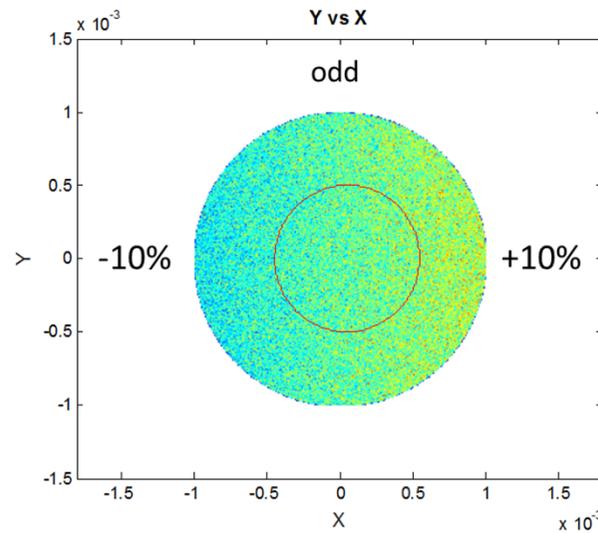
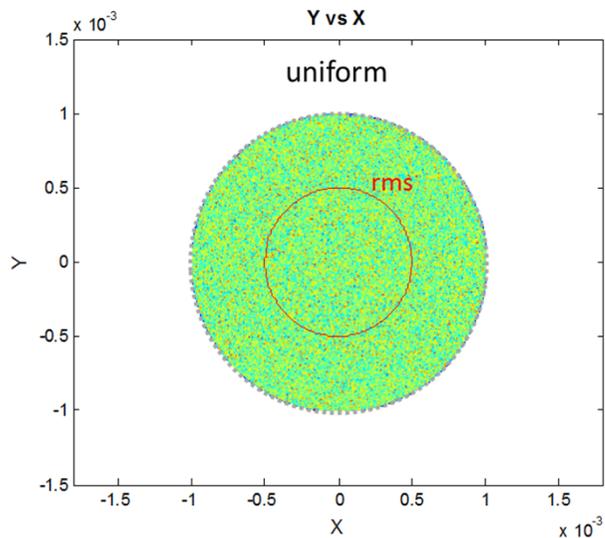


Astra generator
Lt=20psec, rt=2psec
Gun
60 MV/m, 0.2234 T

transverse distribution at cathode

uniform, $R = 1 \text{ mm}$
(rms = 0.5 mm)

modifications



mesh properties

during injection: $\Delta z = 1 \mu\text{m} \rightarrow$ up to about 2000 meshlines

$$\Delta t = T_{\text{bunch}}/500$$

2nd order integrator

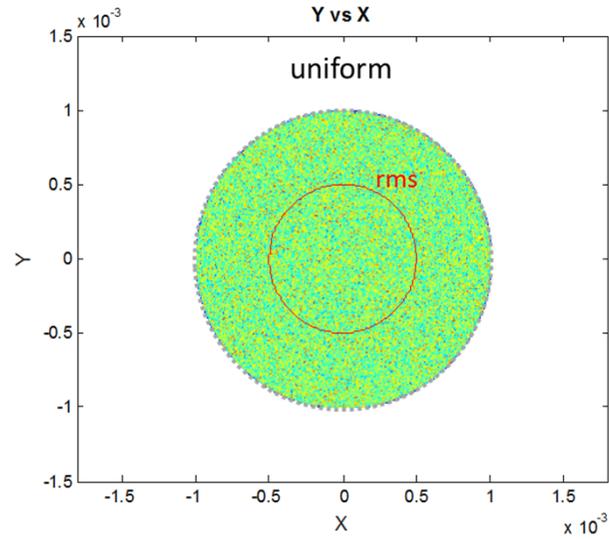
after injection: $\Delta z = Z_{\text{bunch}} / 100$

$$c\Delta t = 1 \text{ mm} \dots 1 \text{ cm}$$

5th order integrator

some longitudinal profiles

at cathode



after 2.6 m

uniform

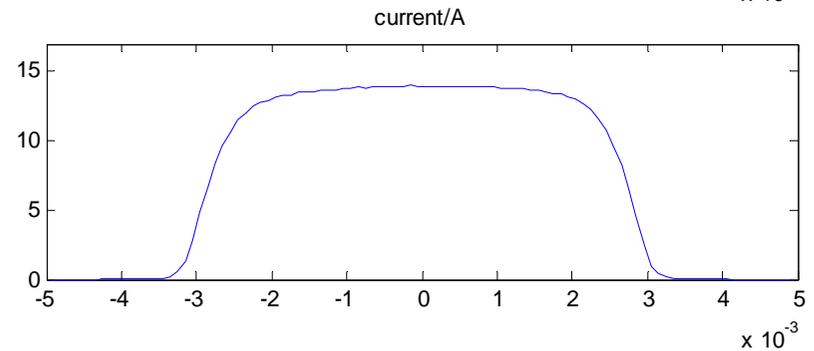
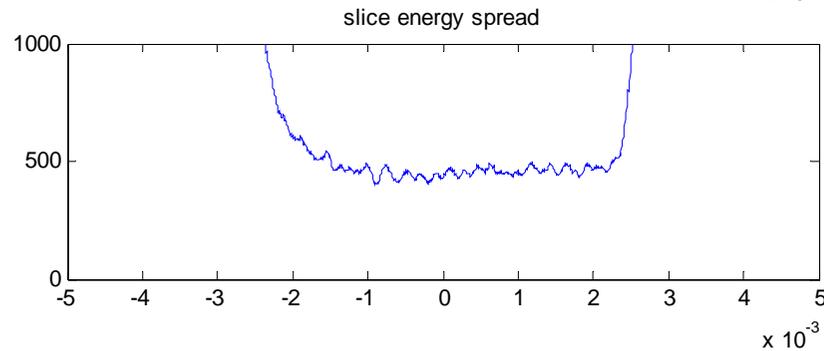
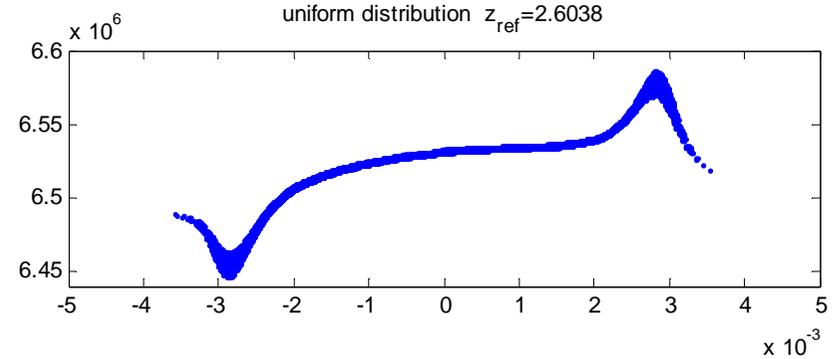
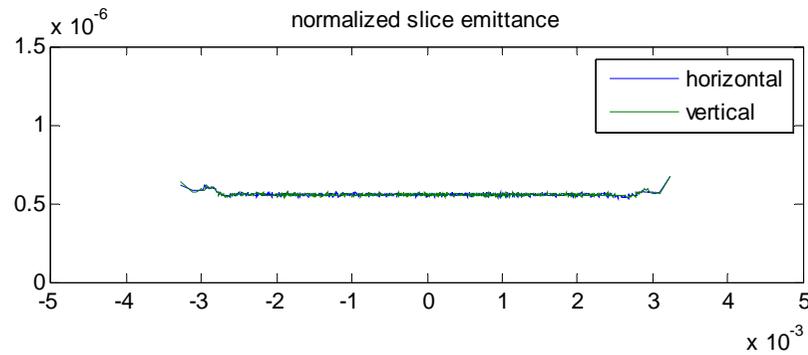
$$\epsilon\gamma\beta/\mu\text{m} = 0.949, 0.949$$

$$\beta_{\text{twiss},x,y}/\text{m} = 2.14, 2.14$$

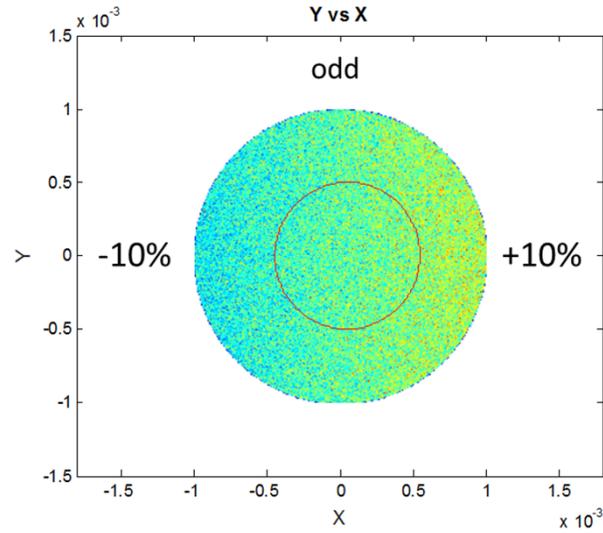
$$\sigma_{E,\text{slice}}/\text{eV} = 443.2$$

projected

averaged for $|z| < 1\text{mm}$



at cathode



after 2.6 m

odd, 10%

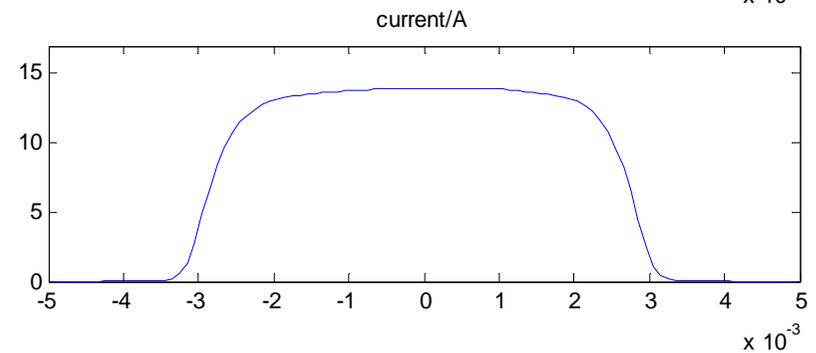
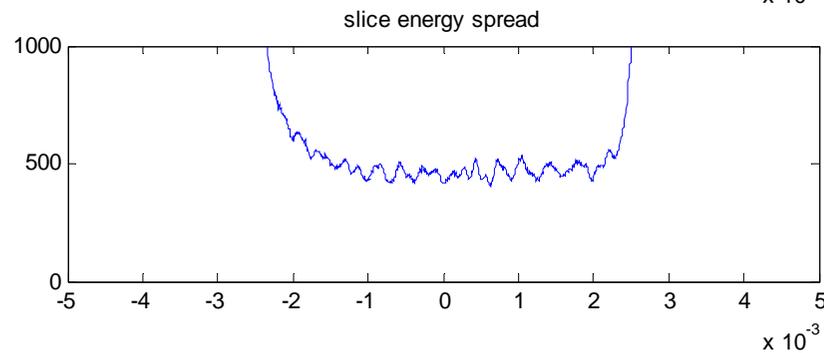
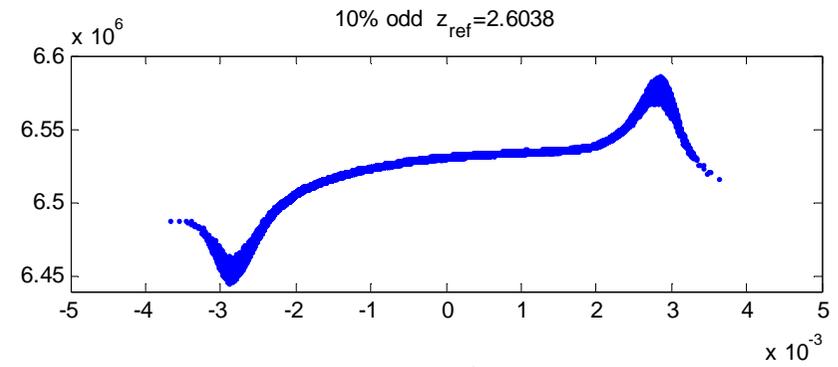
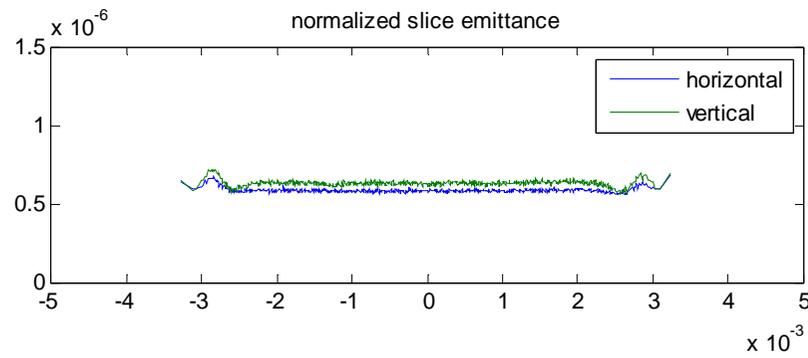
$$\epsilon\gamma\beta/\mu\text{m} = 0.964, 0.985$$

$$\beta_{\text{twiss},x,y}/\text{m} = 2.11, 2.12$$

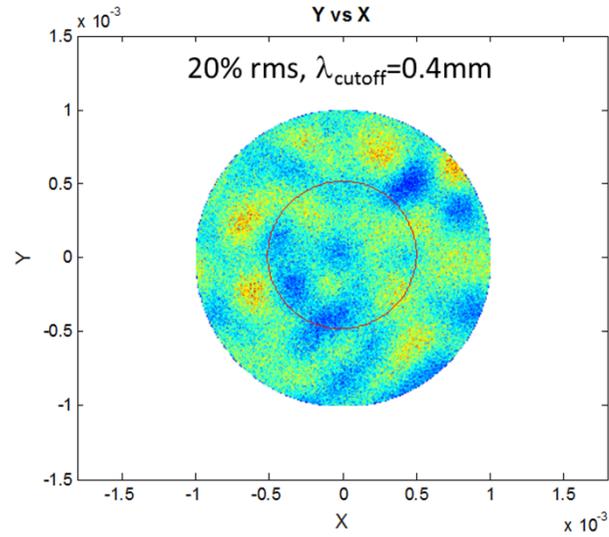
$$\sigma_{E,\text{slice}}/\text{eV} = 463.1$$

projected

averaged for $|z| < 1\text{mm}$



at cathode



after 2.6 m

random, 20% rms, $\lambda_{\text{cutoff}}=0.4\text{mm}$

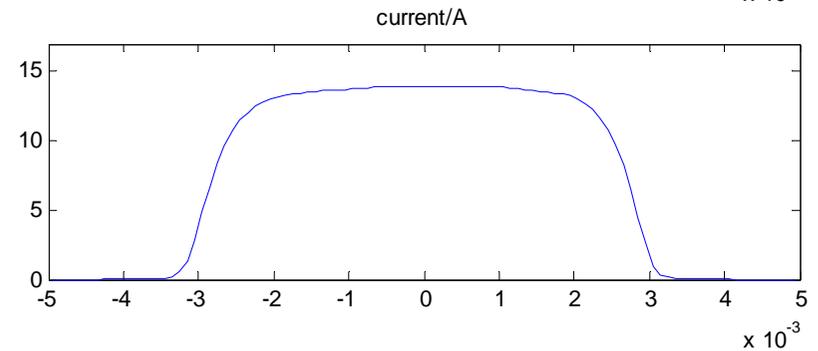
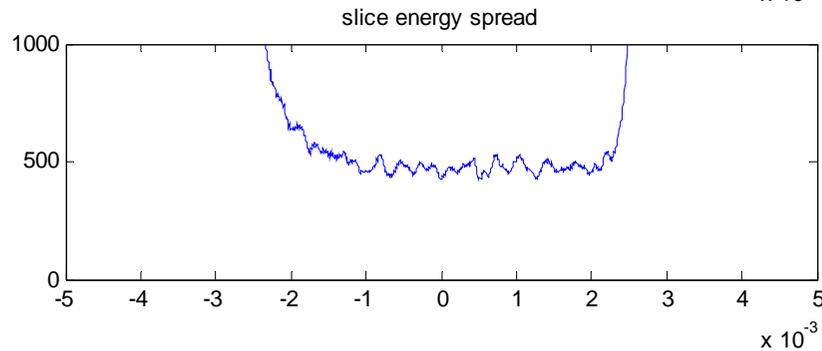
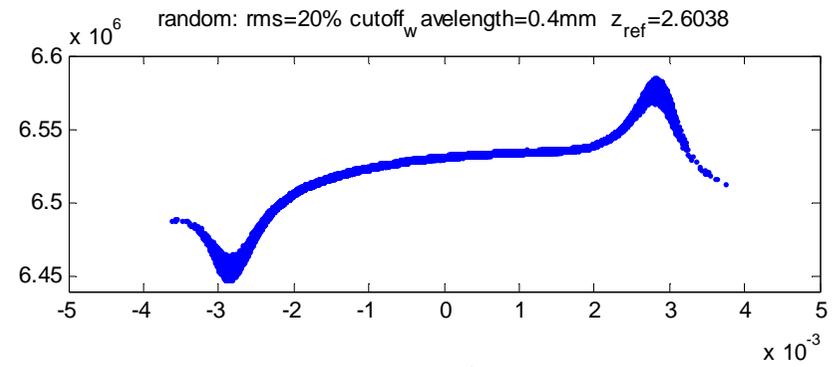
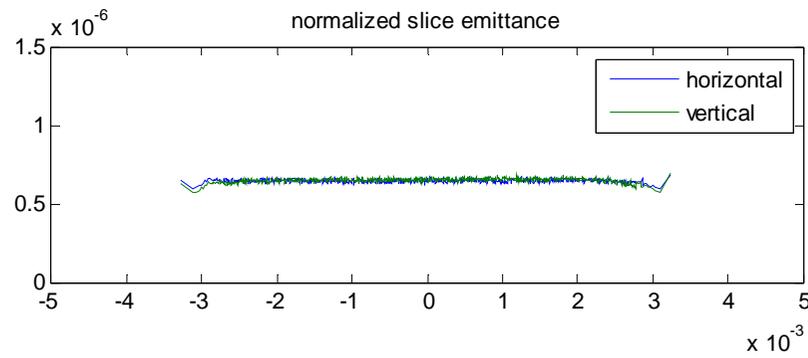
$\epsilon\gamma\beta/\mu\text{m} = 1.05, 0.98$

$\beta_{\text{twiss},x,y}/\text{m} = 2.15, 2.19$

$\sigma_{E,\text{slice}}/\text{eV} = 478.8$

projected

averaged for $|z|<1\text{mm}$

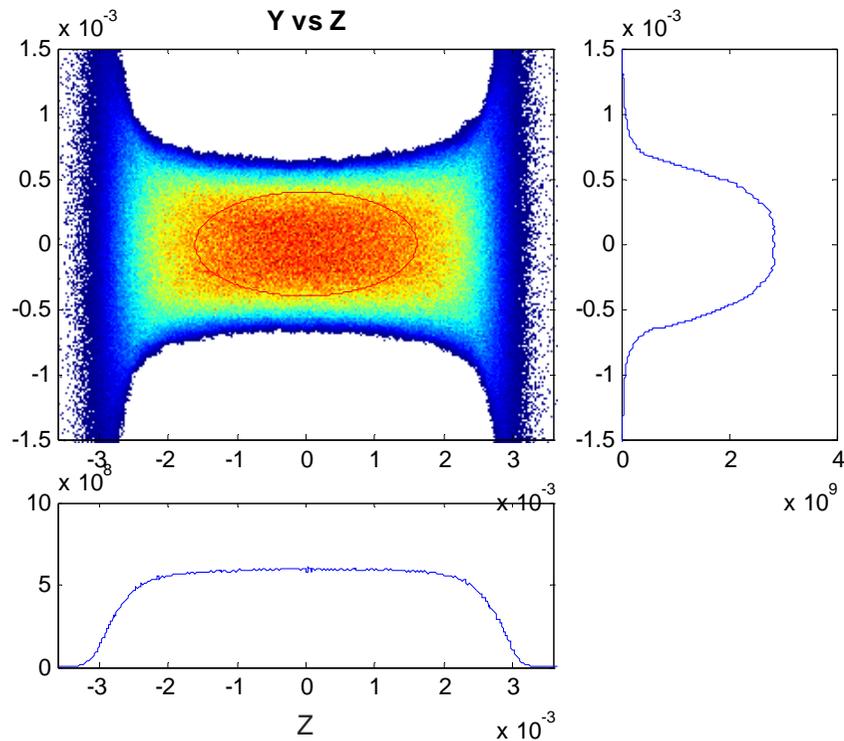
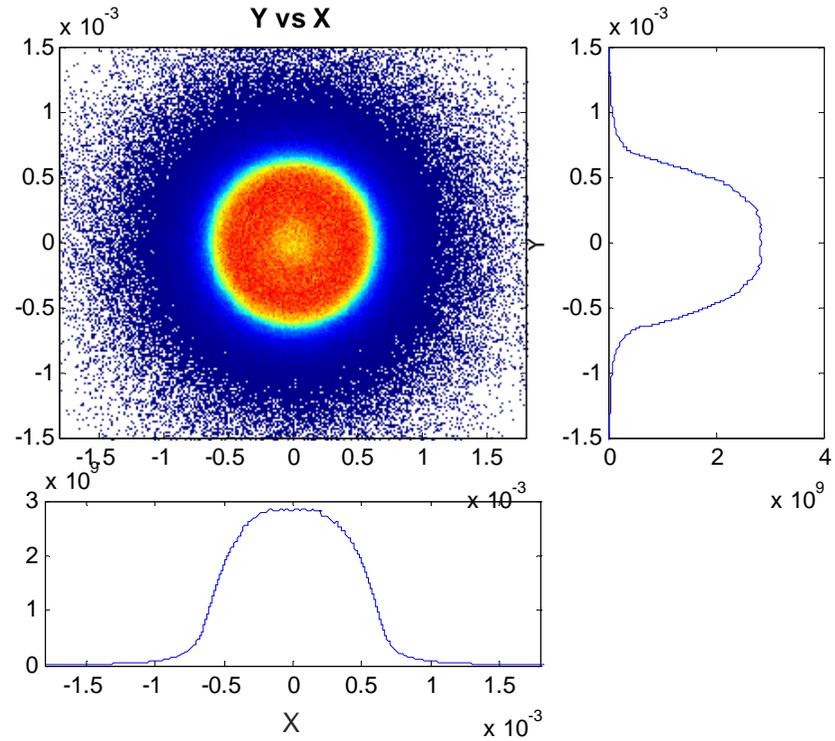
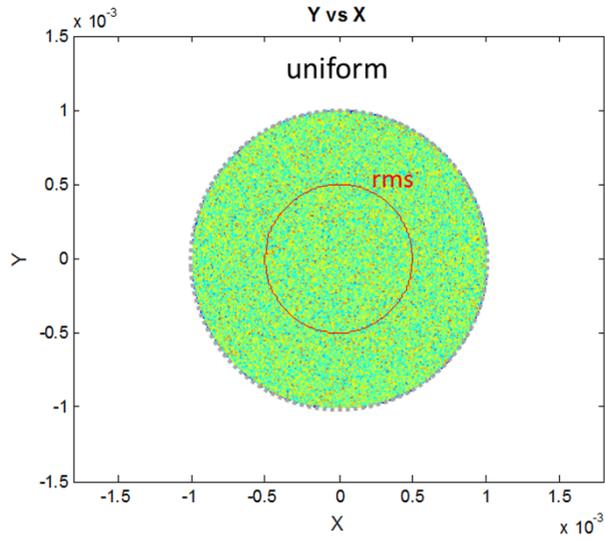


projections to

xy -plane (front view)

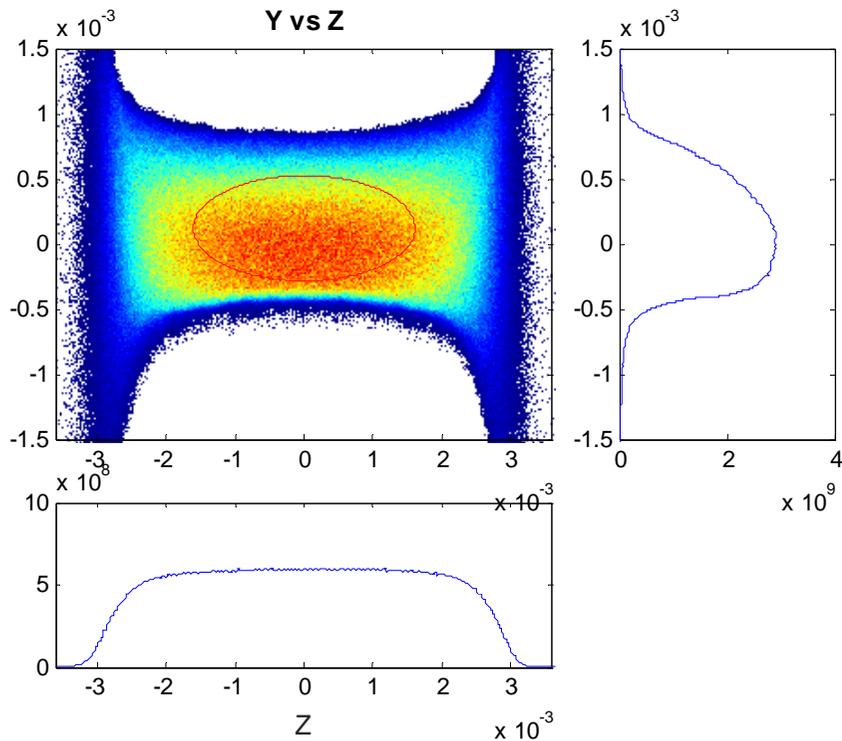
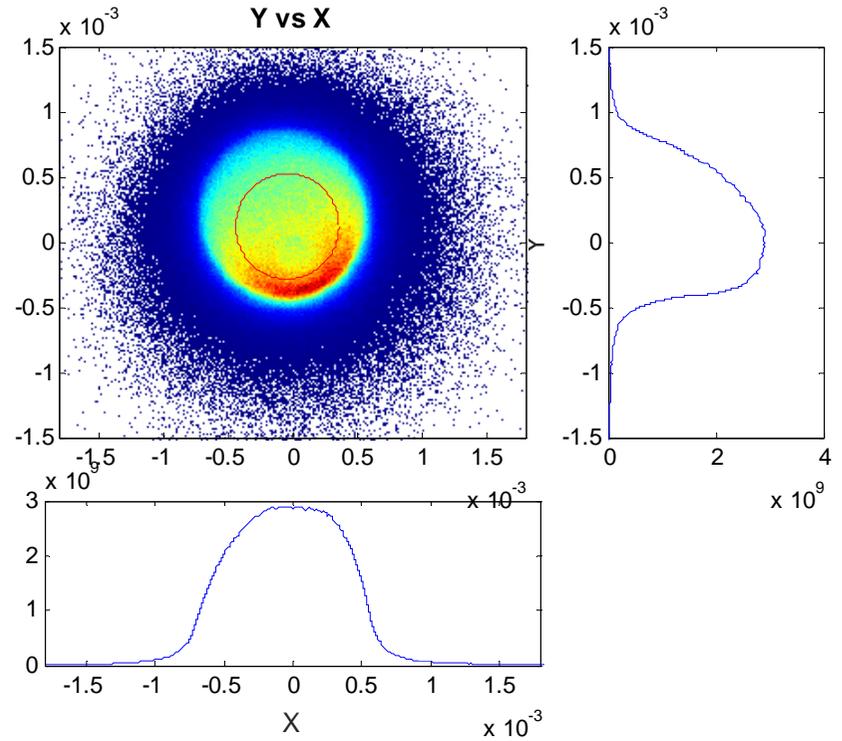
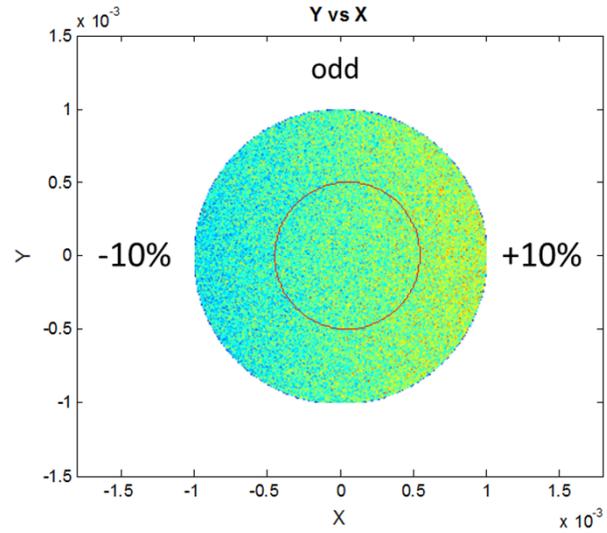
yz -plane (top view)

at cathode



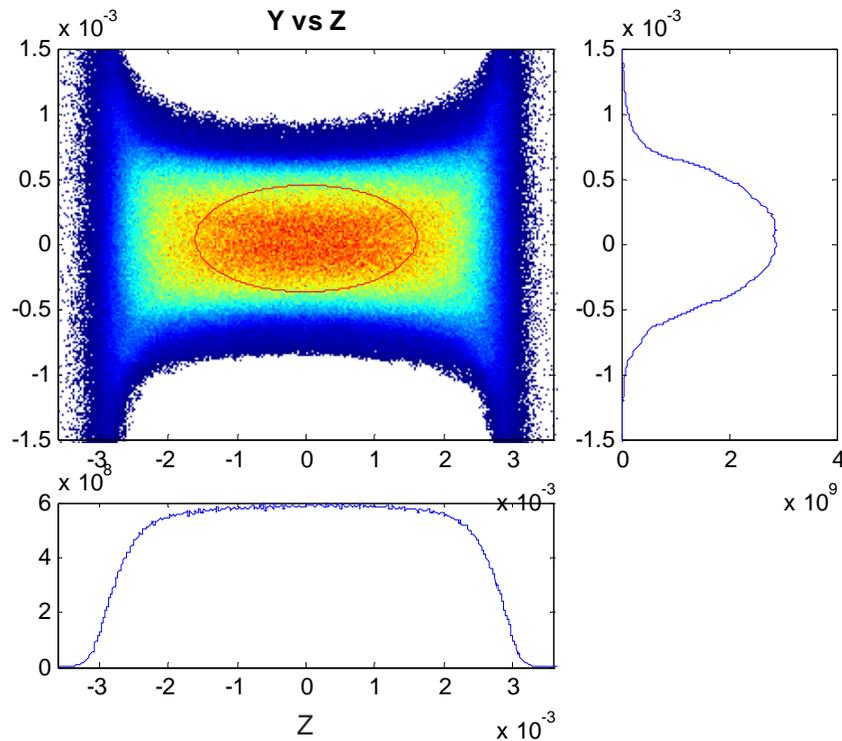
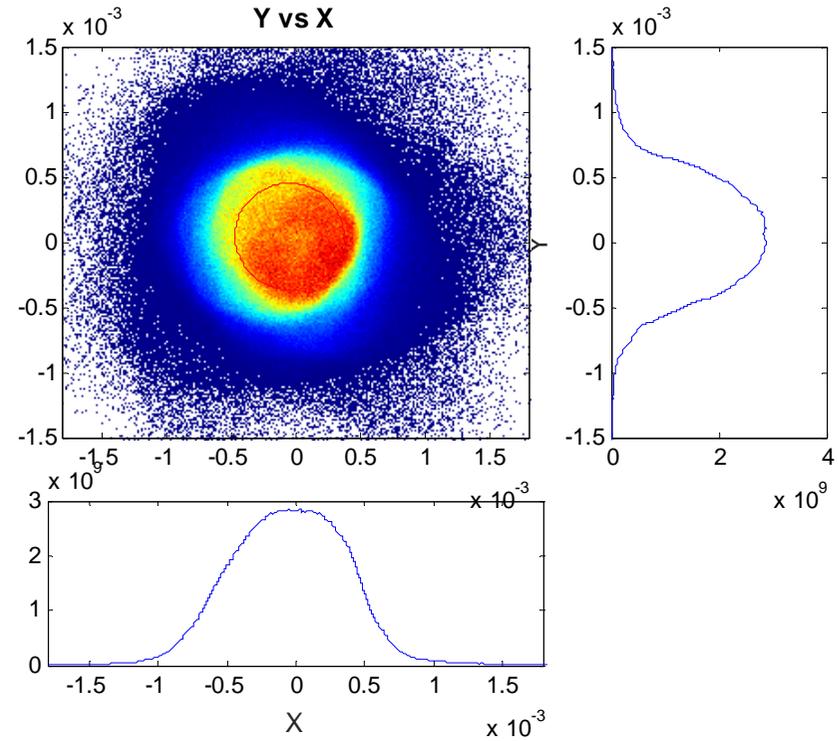
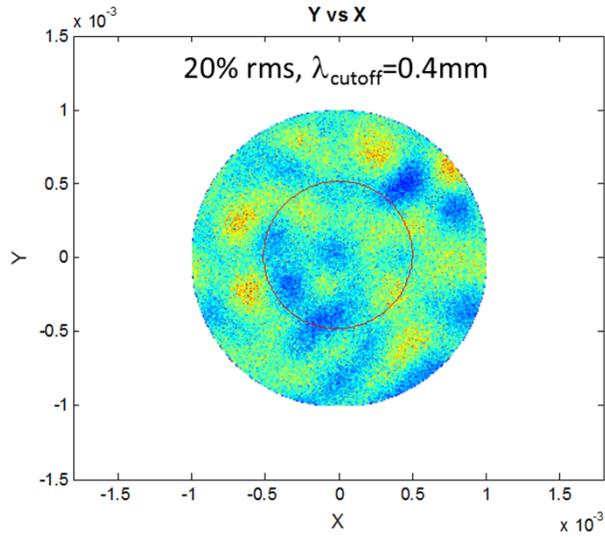
after 2.6 m
uniform

at cathode

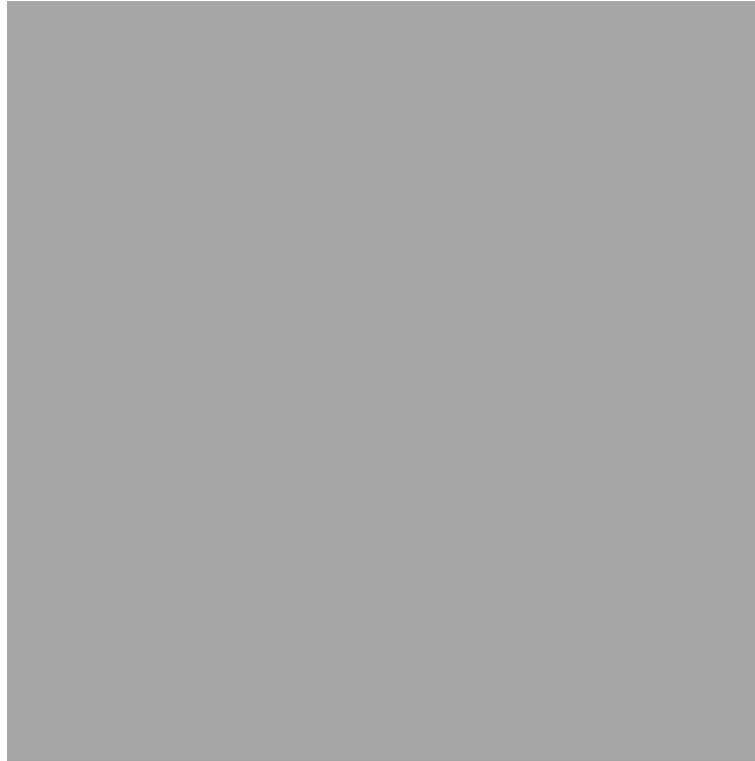


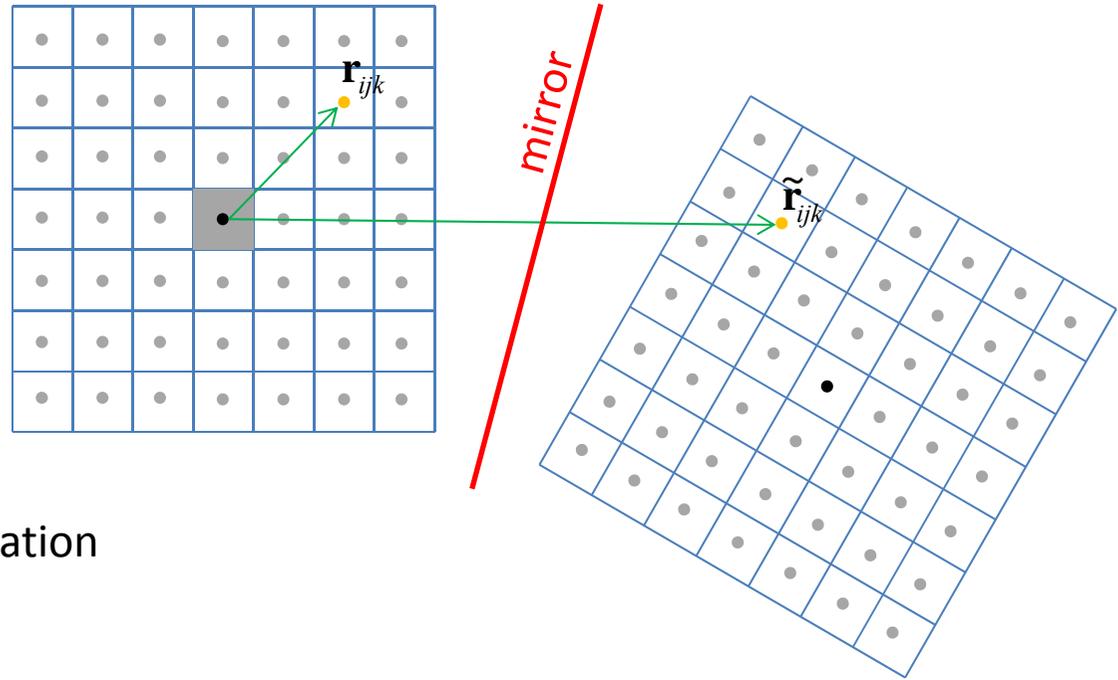
after 2.6 m
odd, 10 %

at cathode



after 2.6 m
random, 20% rms, $\lambda_{\text{cutoff}}=0.4\text{mm}$





$$\tilde{\mathbf{r}}_{ijk} = \mathbf{M}\{\mathbf{r}_{ijk}\} \quad \text{mirror transformation}$$

$$\tilde{v}_{ijk} = \int K(\mathbf{M}\{\mathbf{r}_{ijk}\} - \mathbf{r}') \rho(\mathbf{r}') dV'$$

$$= \sum_{uvw} \int_{\Delta V_{uvw}} K(\mathbf{M}\{\mathbf{r}_{ijk}\} - \mathbf{r}') \frac{q_{uvw}}{\Delta V} dV'$$

$$= \sum_{uvw} q_{uvw} \int_{\Delta V} K(\mathbf{M}\{\mathbf{r}_{ijk}\} - \mathbf{r}' - \mathbf{r}_{uvw}) \frac{dV'}{\Delta V}$$

$$= \sum_{uvw} q_{uvw} G(\mathbf{M}\{\mathbf{r}_{ijk}\} - \mathbf{r}_{uvw})$$

$$\text{with } K(\mathbf{r}) = \frac{1}{4\pi\epsilon_0 r}$$

$$\text{special case: } \mathbf{M}\{\mathbf{r}_{ijk}\} - \mathbf{r}_{uvw} = \Delta \begin{pmatrix} i-u \\ j-v \\ \alpha-k-w \end{pmatrix}$$

$$G(\mathbf{M}\{\mathbf{r}_{ijk}\} - \mathbf{r}_{uvw}) = g_{(i-u)(j-v)(-k-w)}$$

→ convolution